

S/N 09/944,983

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Paul A. Farrar	Examiner:	Maurina T. Rachuba
Serial No.:	09/944,983	Group Art Unit:	3723
Filed:	August 30, 2001	Docket No.:	1303.018US1
Title:	CHEMICAL MECHANICAL POLISHING SYSTEM AND PROCESS		

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This responds to the Office Action dated on January 20, 2006. Please amend the above-identified patent application as follows.